

Application Serial No. 10/087,510  
Amendment dated April 13, 2004  
Response to Office Action dated January 14, 2004



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*File changed*

Application No. : 10/087,510  
Applicants : SETHURAMAN JAYASHANKAR ET AL  
Filed : March 1, 2002  
Title : SINGLE LAYER RESIST LIFT-OFF  
PROCESS AND APPARATUS FOR  
SUBMICRON STRUCTURES  
  
Group Art Unit : 1765  
Examiner : Shamim Ahmed  
  
Docket No. : 011333

I hereby certify that this  
correspondence is being deposited with  
the United States Postal Service as first  
class mail in an envelope addressed to:  
Commissioner for Patents, P.O. Box  
1450, Alexandria, Virginia 22313-1450  
on

this 13th day of April, 2004.

*Bea MacDonald*  
Buchanan Ingersoll, P.C.

AMENDMENT

Pittsburgh, Pennsylvania 15219

April 13, 2004

Commissioner for Patents  
Post Office Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to Office Action dated January 14, 2004, please amend this application as set  
forth hereinafter.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2

04/22/2004 of this paper.  
RHOLLAND 00000001 024553 10087510

01 FC:1202 18. Remarks begin on page 7 of this paper.